



00862.022173

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of:) Eveninan K.T. Navyen
Yasuhiro SHIMADA et al.	: Examiner: K.T. Nguyen
	: Group Art Unit: 2881
Application No.: 09/819,906) : Confirmation No.: 5368
Filed: March 29, 2001) Committation No.: 3308
For: ELECTRON OPTICAL SYSTEM ARRAY, METHOD OF MANUFACTURING THE SAME, CHARGED-PARTICLE BEAM EXPOSURE APPARATUS, AND DEVICE MANUFACTURING METHOD	December 12, 2003 December 12, 2003

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

FIFTH SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Sir:

Further to the Information Disclosure Statement filed on October 23, 2001, the Supplemental Information Disclosure Statement filed on January 29, 2003, the Second Supplemental Information Disclosure Statement filed on June 4, 2003, the Third Supplemental Information Disclosure Statement filed on October 14, 2003, and the Fourth Information Disclosure Statement filed on November 6, 2003, and in compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed PTO-1449 form. Copies of the listed documents are also enclosed.

U.S. Patent Nos. 4,419,182, 4,569,033 and 5,260,579 were cited in a Notice of Art Cited by the Examiner (PTO-892 Form) attached to a Notice Allowance issued November 10, 2003, in copending U.S. patent application number 09/819,737.

Applicants request that the above information be considered by the Examiner and

that a copy of the enclosed PTO-1449 form be initialed and returned indicating that such

information has been considered.

No fee is believed to be due with the filing of this paper. Nevertheless, the

Commissioner is authorized to charge Deposit Account No. 06-1205 should any fee be

deemed necessary for filing this paper.

Applicants' undersigned attorney may be reached in our Washington D.C. office

by telephone at (202) 530-1010. All correspondence should continue to be directed to our

address given below.

Respectfully submitted,

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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEM

LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)

December 12, 2003

ATTY DOCKET NO. 00862.022173

APPLICATION NO. 09/819,906

APPLICANT Yasuhiro SHIMADA et al.

FILING DATE March 29, 2001

GROUP 2881

December 12, 2003			ING DATE March 29, 2001 GROUP 2			
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*EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE
	US-4,569,033	02/04/1986	Collins et al.	364	845	
	US-5,260,579	11/09/1993	Yasuda et al.	250	492.2	
	US-4,419,182	12/06/1983	Westerberg et al.	156	644	· · · · · · · · · · · · · · · · · · ·
	US-4,607,167	08/19/1986	Petric	250	492.2	
	US-6,072,251	06/06/2000	Markle	310	12	
· · · · · · · · · · · · · · · · ·	····	FOREI	GN PATENT DOCUMENTS		_l	
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
	2001-126651	05/11/2001	Japan			Abstract
	6-44093	02/18/1994	Japan			Partial
		OTHER DOCUMENT(S) (In	cluding Author, Title, Date, Pertinent Pages, Etc.)		
						
EXAMINER			DATE CONSIDERED			
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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.